



Attorney Docket 0553-0185.01

A F
JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
Sakama et al.)
Serial No.: 10/669,284)
Filed: September 24, 2003)
For: Semiconductor Device And)
A Method Of Manufacturing The Same)
Art Unit: 2826)
Examiner: Johannes P. Mondt)

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

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Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 10/3/05
Signature Date

AMENDMENT C (AFTER FINAL)

Sir:

In response to the Final Rejection of July 1, 2005, please enter the following amendment in
the above-identified application: